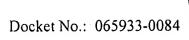
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Ryosuke USUI, et al. : Confirmation Number: 3812

Application No.: 10/813,629 : Group Art Unit: 2814

Filed: March 31, 2004 : Examiner: Dilinh P. Nguyen

For: SEMICONDUCTOR MODULE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

10/813,629

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

A copy of the Chinese second office action, together with an English language version

thereof, is attached for the Examiner's information.

Please note that all the references cited in the corresponding Chinese second office action

were previously submitted to U.S. Patent & Trademark Office on July 13, 2006.

Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 500417 and please credit any excess fees to

such deposit account.

Respectfully submitted,

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Facsimile: 202.756.8087 **Date: March 15, 2007**

Please recognize our Customer No. 20277 as our correspondence address.

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SHEET 1 OF 1

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				APPLICANT Ryosuke USUI, et al.								
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U.S. PATENT DOCUMENTS												
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)												
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	Chinese Second Office Action issued in corresponding Chinese Patent Application											
	No. 200410032008.2 , dated on December 15, 2006.											
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.